

**PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)  
(Large Entity)**Docket No.  
FIS920000372US1

In Re Application Of: S. Iyer, et al.

Serial No.  
09/878,556Filing Date  
06/11/01Examiner  
Jack S J ChenGroup Art Unit  
2813Invention: **METHOD OF FORMING VARIABLE OXIDE THICKNESSES ACROSS SEMICONDUCTOR CHIPS****TO THE ASSISTANT COMMISSIONER FOR PATENTS:**

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of 08/14/02 above-identified application.  
Date

The requested extension is as follows (check time period desired):

☐ One month    ☒ Two months    ☐ Three months    ☐ Four months    ☐ Five months

from: 11/14/02  
Dateuntil: 01/14/03  
Date

The fee for the extension of time is \$410 and is to be paid as follows:

- ☐ A check in the amount of the fee is enclosed.  
☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 09-0458(FI-037)  
A duplicate copy of this sheet is enclosed.  
☒ If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 09-0458(FI-037)  
A duplicate copy of this sheet is enclosed.

01/30/2003 RTYSON 00000001 090458 09076556

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**FAX RECEIVED**

JAN 14 2003

TECHNOLOGY CENTER 2800

Dated: 01/14/03

Ira D. Blecker, Reg. # 79,894  
(845) 894-2580IBM Corporation, M/D 482  
2070 Route S2  
Hopewell Junction, NY 12533-6531

I certify that this document and fee is being deposited  
1/14/03 via facsimile  
and is addressed to the  
Assistant Commissioner for Patents, Washington, D.C.  
20231.  
Signature of Person Mailing Correspondence

Hilda Heinlein

Typed or Printed Name of Person Mailing Correspondence

cc: